Docket No.: HEI-020 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 0/590719

In re Application of

Confirmation No.

Maki TAKIZAWA et al.

U.S. Patent Application No.: -----

Group Art Unit: -----

Filed: herewith

For:

QUARTZ OSCILLATOR MANUFACTURING METHOD AND QUARTZ OSCILLATOR

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application and no certification or fee is required.

Respectfully submitted,

KANESAKA BERNER & PARTNERS

Manabu Kanesaka

Registration No. 31,467

1700 Diagonal Road, Suite 310 Alexandria, Virginia 22314 (703) 519-9785 MAN/eb Facsimile: (703) 519-7769

Date: August 25, 2006

## IAP5 Rec'd PCT/PTO 25 AUG 2008 1 of 1

## ATTY. DOCKET NO. U.S. APPLICATION NO. HEI-020 Not yet assigned INFORMATION DISCLOSURE APPLICANT **10** Maki TAKIZAWA et al /590719 CITATION IN AN APPLICATION FILING DATE herewith (PTO-1449) U.S. PATENT DOCUMENTS FILING **EXAMINER'S** NAME **CLASS SUBCLASS** DATE **INITIALS** PATENT NO. DATE FOREIGN PATENT DOCUMENTS 10 m Translation EXAMINER'S COUNTRY CLASS **SUBCLASS** PATENT NO. DATE **INITIALS** /AK/ abstract JP2004-77453 03/11/2004 Japan /AK/ Japan JP2002-243451 08/28/2002 abstract /AK/ abstract 03/25/2004 Japan JP2004-93158 abstract /AK/ JP2003-28645 01/29/2003 Japan 7AK7 Japan abstract JP2004-079869 03/11/2004 /AK/ abstract JP2001-196891 07/19/2001 Japan OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) DATE CONSIDERED **EXAMINER** /Arnold Kinkead/ 04/27/2008

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.